

-	399	(451/443).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:36
-	691	(451/56).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:36
-	10964	polishing adj pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:08
-	4832	(polishing adj pad) and thickness	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:06
-	1836	((polishing adj pad) and thickness) and light	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:08
-	1372	(((polishing adj pad) and thickness) and light) and condition\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:07
-	1006	(polishing adj pad) with thickness	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:08
-	341	((polishing adj pad) and thickness) and light and conditioning	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/09 16:08
-	823	(451/8).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:35
-	1505	(451/5).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:35
-	695	(451/56).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:36
-	401	(451/443).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:36
-	455	(451/72).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:36
-	134	((451/8).CCLS.) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:42
-	161	((451/5).CCLS.) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:46
-	26	((451/56).CCLS.) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:48
-	10	((451/443).CCLS.) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:48

-	14	((451/72).CCLS.) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:49
-	14404	polishing with pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:49
-	684	(polishing with pad) and light and detector	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:50
-	520	((polishing with pad) and light and detector) and condition\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 09:50
-	451	((polishing with pad) and light and detector) and condition\$3) and thickness	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:03
-	62	(thickness with profile) same conditioning	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:39
-	1493	thickness same conditioning and light	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:39
-	231	(thickness same conditioning and light) and pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:48
-	1744	profile with control and conditioning	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:48
-	294	(profile with control and conditioning) and pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:49
-	159	(profile with control and conditioning) and light and pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:53
-	64278	("451").CLAS.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:53
-	0	("21andlightandprofileandconditioning").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:54
-	134	((("451").CLAS.) and light and profile and conditioning	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:58
-	334	((("451").CLAS.) and light and thickness and conditioning	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 10:58
-	283	((("451").CLAS.) and light and thickness and conditioning) and pad	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 11:08
-	0	ching-yen with lin.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 11:08

-	4	jen-chieh with tung.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 11:10
-	0	chia-ching with hsieh.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/08/20 11:10